

Application No.	Applicant(s)	
09/908,970	SEKIYA ET AL.	
Examiner	Art Unit	
Cheukfan Lee	2622	

SEARCHED				
Class	Subclass	Date	Examiner	
358	475,474	3/18/2005	C.L.	
	406,504			
	509,505			
	404,444			
	486,488			
399	32,31			
	10, 11			
	9, 376			
	367			
348	96, 97			
355	40,41			
	408,407			
	401,402			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST search: see result	3/18/2005	C.L.		
Kim Williams on combining Rotter et al. U.S. 6,134,496 the secondary reference with AAPR.				
Brian Werner on Technology of 6,134,496				
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